What is claimed is:

- 1. An electronic apparatus, comprising:
- a semiconductor element installed within a housing;
- a heat-receiving portion for receiving heat generated from said semiconductor element; and
 - a heat radiation portion being connected between said heat radiation portion and said heat-receiving portion through conduits, wherein a heat diffusion plate is provided between said heat-receiving portion and said semiconductor element.
- 2. The electronic apparatus, as described in the claim 1, wherein:

said heat diffusion plate is made of a metal defining a hermetically closed space therein, for enclosing evaporation medium within an inside thereof.

3. The electronic apparatus, as described in the claim 2, wherein:

within the inside of said hermetically close space is attached a metal plate, expanding radial directions from a portion of said semiconductor element.

4. The electronic apparatus, as described in the claim 3, wherein:

said metal plate is formed zigzagging.

- 5. The electronic apparatus, as described in the claim 1, wherein:
- said heat-receiving portion comprises four (4) pieces of liquid circulation flow passages within an inside thereof.
 - 6. The electronic apparatus, as described in the claim 1,

wherein:

said liquid circulation flow passages are defined by three (3) pieces of partition walls attached on an interior wall surface of an upper cover for building up said heat-receiving portion.